Practitioner's Docket No. 1153-010 Div2

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In papplication of:

JUL 3 0 2004 8

James E. Moon et al

Application No.: 10/003,851

Group No.: 1763

Filed: 11/02/2001

Examiner: Allan W. Olsen

For: Method for Fabricating MEMS and Microfluidic Devices using SMILE, Latent Masking, and

Delayed LOCOS Techniques

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT TRANSMITTAL AFTER FINAL

1. Transmitted herewith is an amendment for this application.

STATUS

2. Applicant is a small entity. A statement was already filed.

EXTENSION OF TERM

3. The proceedings herein are for a patent application and the provisions of 37 C.F.R. 1.136 apply. Applicant believes that no extension of term is required. However, this conditional petition is being made to provide for the possibility that applicant has inadvertently overlooked the need for a petition for extension of time.

FEE FOR CLAIMS

4. The fee for claims (37 C.F.R. 1.16(b)-(d)) has been calculated as shown below:

	(Col. 1)	(C	ol. 2)	_(C	ol. 3)		SMALL ENTIT			ITY	
	CLAIMS							·			
	REMAINING		EST NO.								
	AFTER		IOUSLY		ESENT		_			ADDIT.	
	AMENDMENT	PAI	D FOR	EX	(TRA		R	ATE	_	FEE	
TOTAL	6		20	=	0	x	\$	9.00	=	\$	0.00
INDEP.	1		3	=_	0	х	\$_	43.00	=	\$	0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM								0.00	_=_	\$	0.00
								TOTAL			
							ΑI	DDIT. FEE		\$	0.00

No additional fee for claims is required.

FEE DEFICIENCY

5. If an additional extension and/or fee is required, charge Account No. 10-1213.

If an additional fee for claims is required, charge Account No. 10-1213.

Date: 7/30/04

Reg. No.: 52502

Tel. No.: 703-415-1500 Customer No.: 23294 Signature of Practitioner

Alexander D Raring
JONES, TULLAR & COOPER, P.C.

PO Box 2266 Eads Station Arlington, VA 22202

In re Application of)	
James E. Moon et al.)	
)	Art Unit: 1763
Patent Application No.: 10/003,851)	Examiner: Allan W. Olser
Filed: November 2, 2001)	Linding in the control of the contro
1 100. 100. 101. 100.)	
For: METHOD FOR FABRICATING MEMS)	
AND MICROFLUIDIC DEVICES USING)	
SMILE, LATENT MASKING, AND)	
DELAYED LOCOS TECHNIQUES)	

AMENDMENT AND RESPONSE

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are submitted in response to the Office Action of April 30, 2004 in the above-identified patent application.